Accepted Manuscript

Title: Control of hydrophobic surface and wetting states in ultra-flat ZnO films by GLAD method

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PII: S0169-4332(17)30289-1

DOI: http://dx.doi.org/doi:10.1016/j.apsusc.2017.01.266

Reference: APSUSC 35061

To appear in: APSUSC

Received date: 5-12-2016 Revised date: 23-1-2017 Accepted date: 25-1-2017

Please cite this article as: P.-W. Chi, C.-W. Su, D.-H. Wei, Control of hydrophobic surface and wetting states in ultra-flat ZnO films by GLAD method, *Applied Surface Science* (2017), http://dx.doi.org/10.1016/j.apsusc.2017.01.266

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ACCEPTED MANUSCRIPT

Control of hydrophobic surface and wetting states in ultra-flat ZnO films by GLAD method

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